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Bib Data Sheet

CONFIRMATION NO. 8767

<b>SERIAL NUMBER</b> 09/942,626	<b>FILING DATE</b> 08/31/2001 <b>RULE</b>	<b>CLASS</b> 438	<b>GROUP ART UNIT</b> 1751	<b>ATTORNEY DOCKET NO.</b> 213480US0	
<b>APPLICANTS</b> Sei Tsunoda, Tokyo, JAPAN; Hideharu Nobutoki, Tokyo, JAPAN; Noboru Mikami, Tokyo, JAPAN;					
** CONTINUING DATA *****					
** FOREIGN APPLICATIONS *****					
<b>IF REQUIRED, FOREIGN FILING LICENSE GRANTED</b> ** 10/22/2001					
Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no 35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged	Examiner's Signature <i>XMM</i> Initials <i>2/22/2005</i>	<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 0	<b>TOTAL CLAIMS</b> 3	<b>INDEPENDENT CLAIMS</b> 1
<b>ADDRESS</b> 22850					
<b>TITLE</b> Low dielectric constant material having thermal resistance, insulation film between semiconductor layers using the same, and semiconductor device					
<b>FILING FEE RECEIVED</b> 840	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		

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